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U.S. PATENT DOCUMENTS

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	C1	GERGELY et al., "Unbinding process of adsorbed proteins under external stress studied by atomic force microscopy spectroscopy", PNAS, vol. 97, no. 20, pp. 10802-10807 (2000)	
	C2	JUNG et al., "Surfactant Activated Dip-Pen Nanolithography", Nano Letts., vol. 4, no. 11, pp. 2171-2177 (2004)	
	C3	LIM et al., "Direct-Write Dip-Pen Nanolithography of Proteins on Modified Silicon Oxide Surfaces", Angew. Chem. Int. Ed., vol. 42, pp. 2309-2312 (2003)	

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